

<b>Notice of References Cited</b>	Application/Control No. 10/663,251	Applicant(s)/Patent Under Reexamination OHTA ET AL.	
	Examiner Mike Qi	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,233,034	05-2001	Lee et al.	349/141
	B	US-6,069,678	05-2000	Sakamoto et al.	349/141
	C	US-6,075,582	06-2000	Onnagawa et al.	349/145
	D	US-6,088,078	07-2000	Kim et al.	349/141
	E	US-6,091,473	07-2000	Hebiguchi, Hiroyuki	349/141
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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